

High resolution calorimetry with TES

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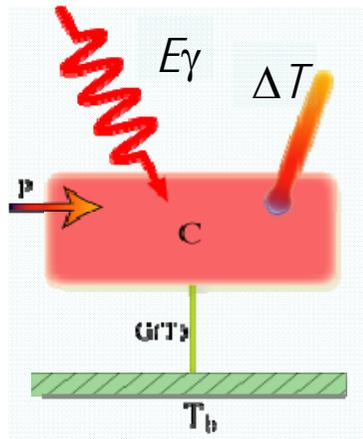
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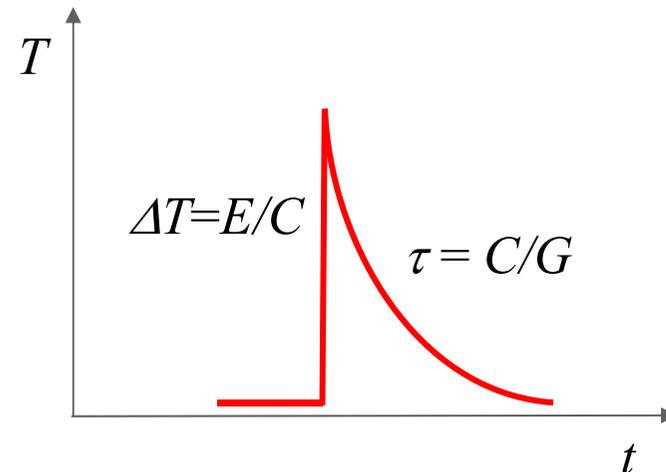
Calorimeter

Calorimeter is a device used to measure the quantity of heat transferred to or from an object.



C = heat capacity

G = Thermal conductance



NEP : thermal fluctuation noise $(4k_B T^2 G)^{1/2}$ W/Hz^{1/2}

$$\Delta E = NEP \tau B^{1/2} \sim (k_B T^2 C B)^{1/2} \text{ J}$$

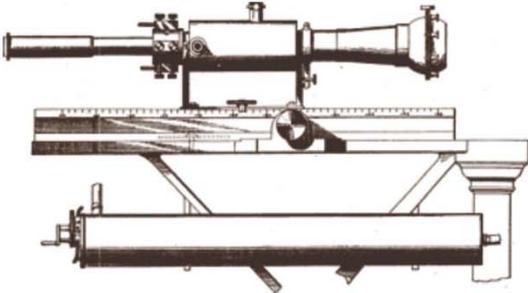


sensors performance best at low temperatures

For $T=0.1$ K , $C = 1$ pJ/K , $B = 1$ Hz $\Leftrightarrow \Delta E=2$ eV

History of Cryogenic Particle Detectors

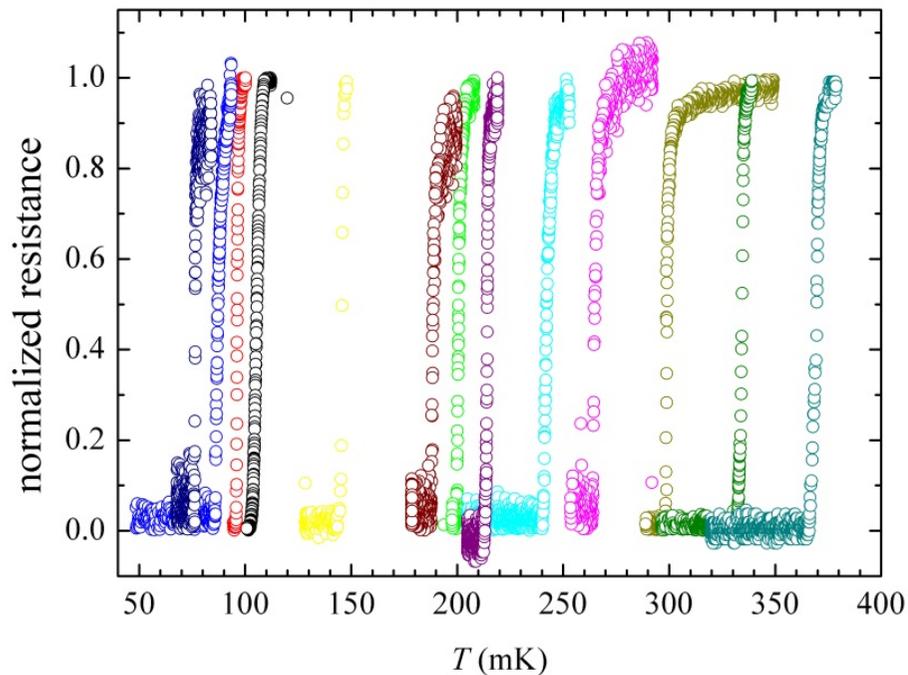
~1845	Mayer, Joule	heat is a form of energy
1876	Langley	bolometer for ir-observations of sun
1903	Curie, Laborte	calorimetric detection of integrated radioactivity
1935	Simon, Kurti	cryogenic version - 50 mK !
1939	Goetz	superconducting transition calorimeter
1949	Andrew, Fowler Williams	detection of single α particles with a superconducting calorimeter
	•	
	•	
	•	
1984	Fiorini, Niinikoski, Moseley, Mather, McCammon	modern type cryogenic particle detectors
today		over 300 scientists are working in this field



Transition-Edge Sensors (TESs)

TES: a microcalorimeter made by a superconducting film operated in the temperature region between the normal and the superconducting state

Ti/Au Bilayer – proximity effect

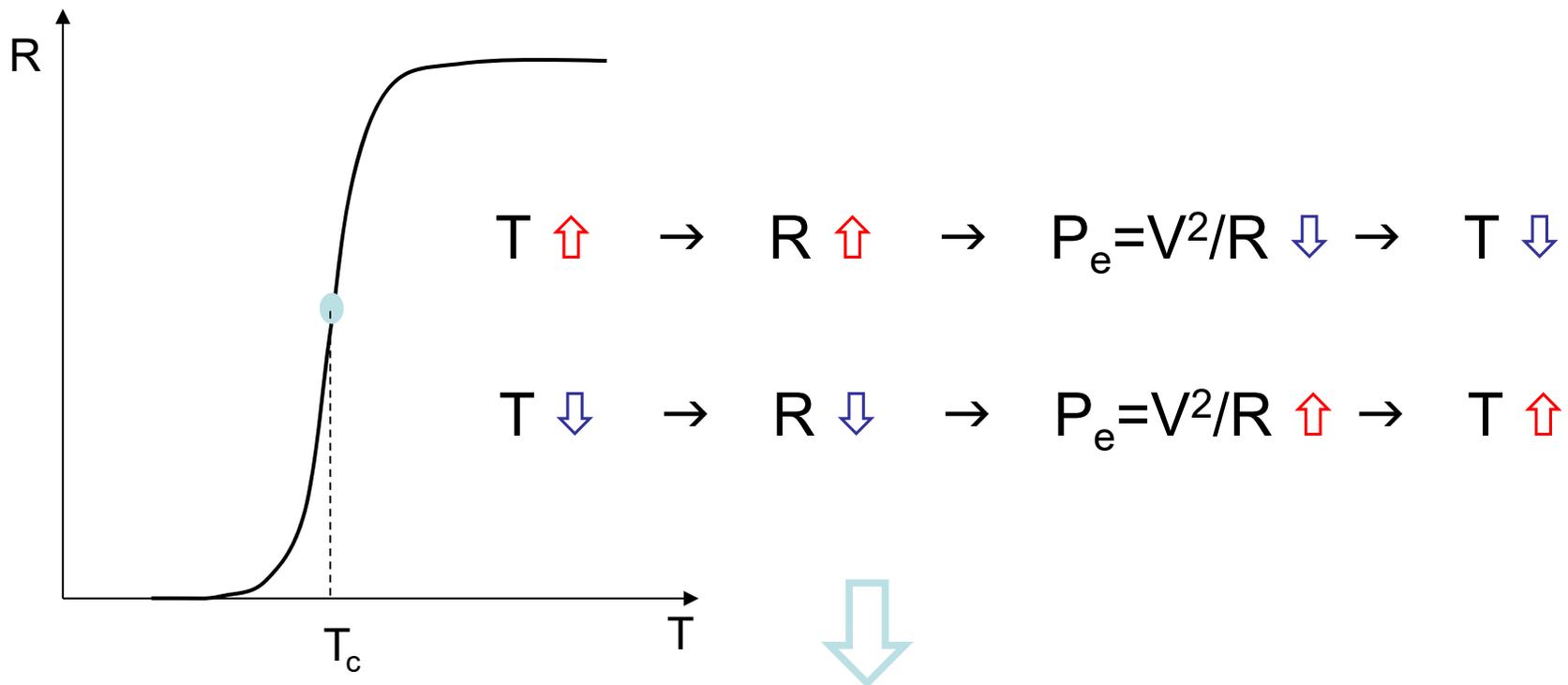


- TESs are very sensitive:
 - ↳ temperature control difficult
 - ↓
 - Voltage biasing and electrothermal feedback
- TESs have low resistance:
 - ↳ difficult readout
 - ↓
 - dc-SQUID amplifier

TES: Electro-thermal feedback

Irwin K. D. , Appl. Phys. Lett. **66** 1998 (1995)

Voltage bias and thermal bath $< T_c$

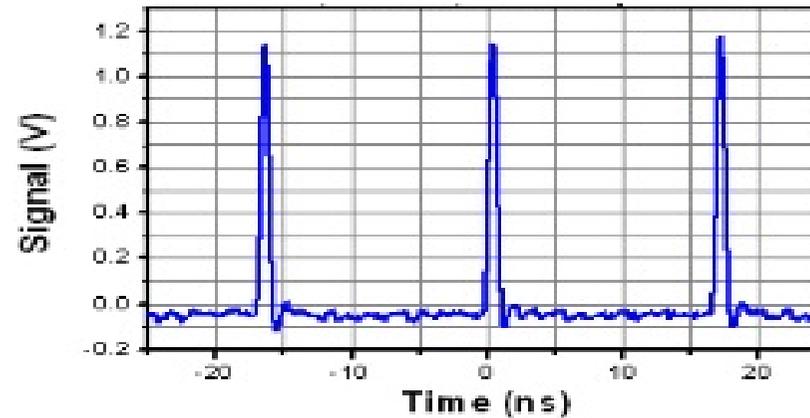


Bias: very easy & response time reduced

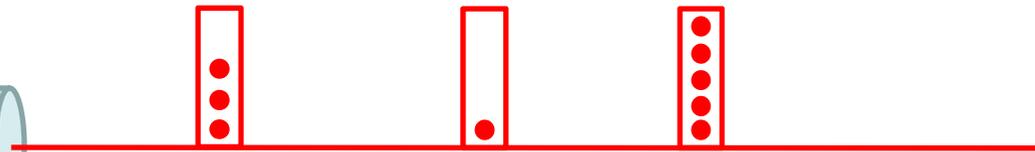
Single Photon detectors

"Classical" Single photon detector

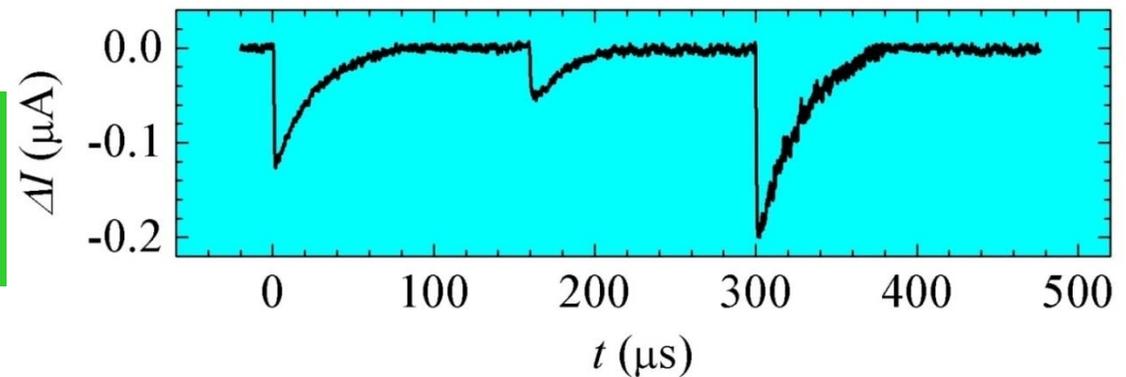
(Photomultiplier, APD, SPAD...)



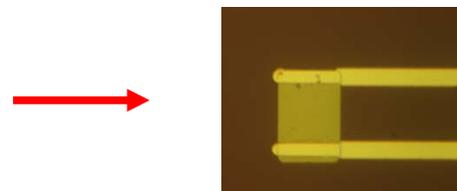
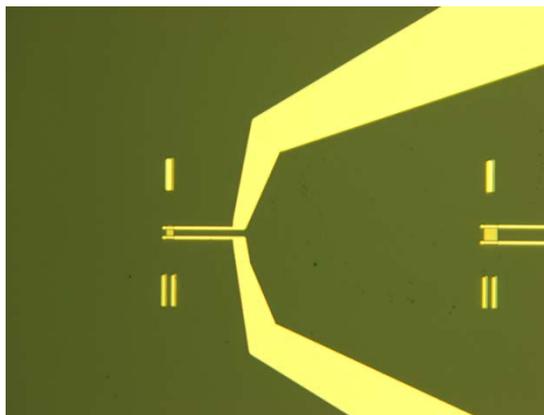
Photon source



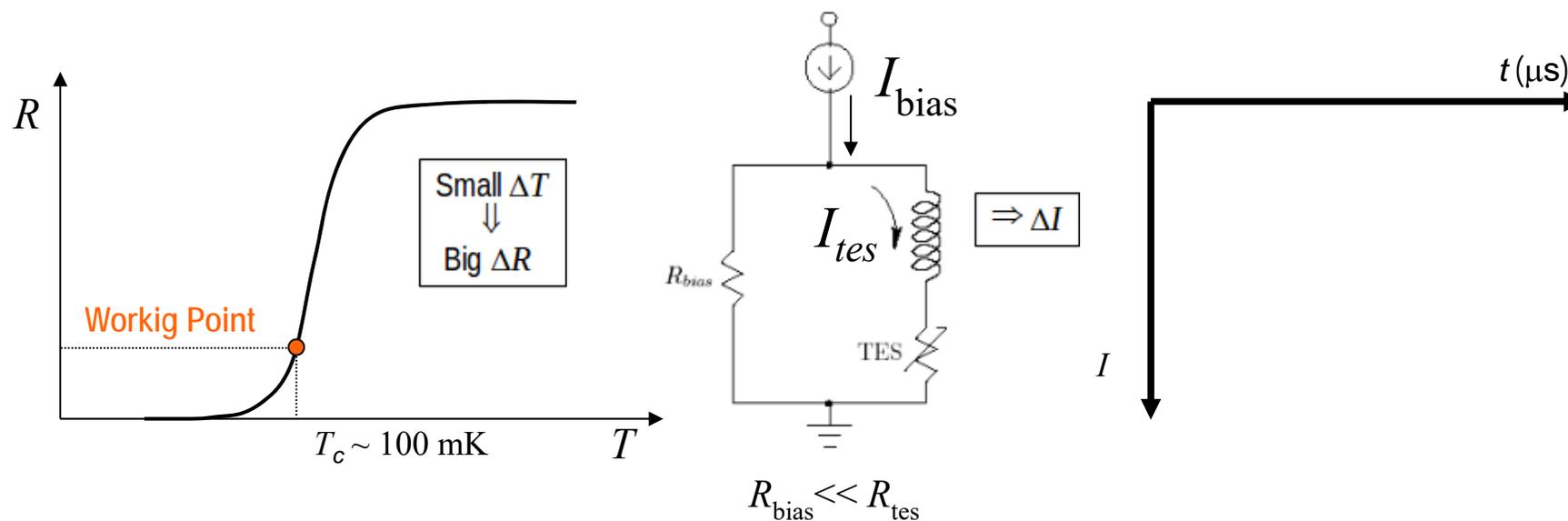
Energy resolving or
Photon number resolving (PNR)
detector



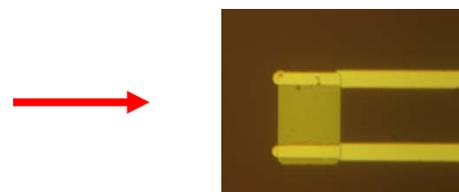
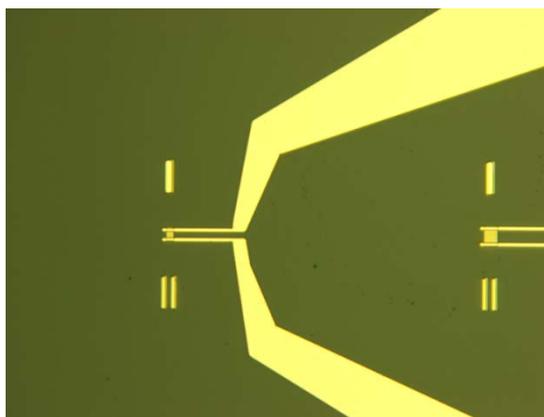
TESs as single photon detectors



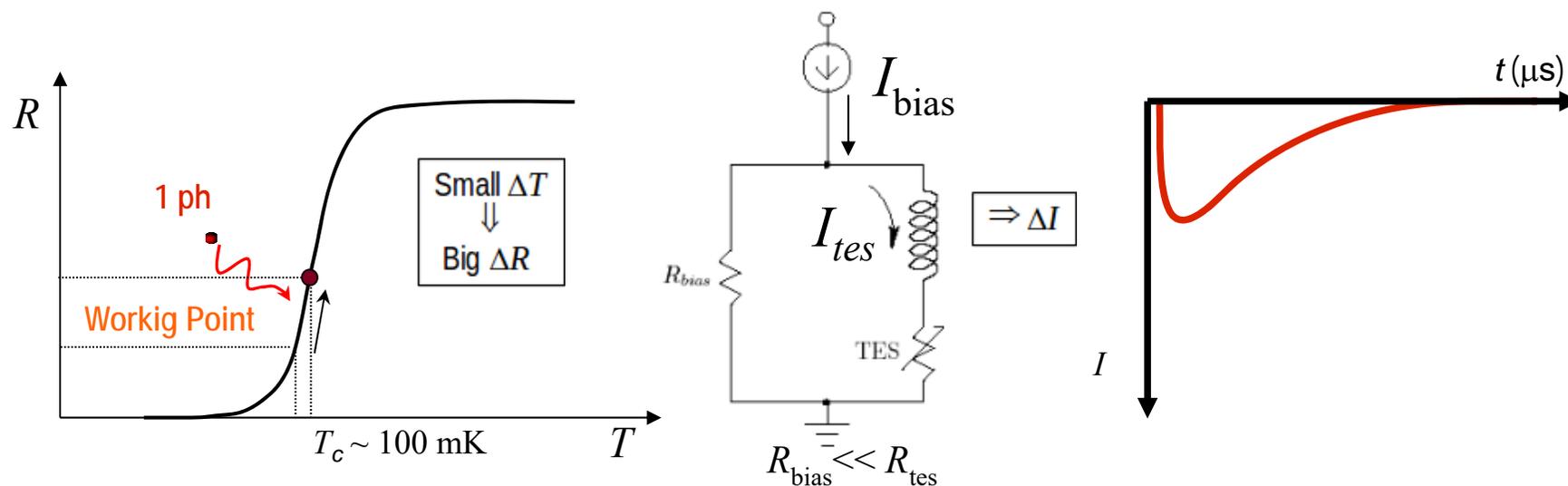
20 μm X 20 μm



TESs as single photon detectors

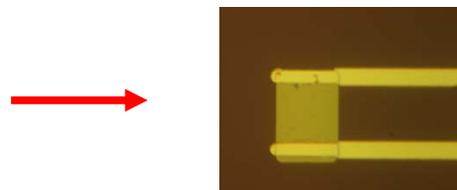
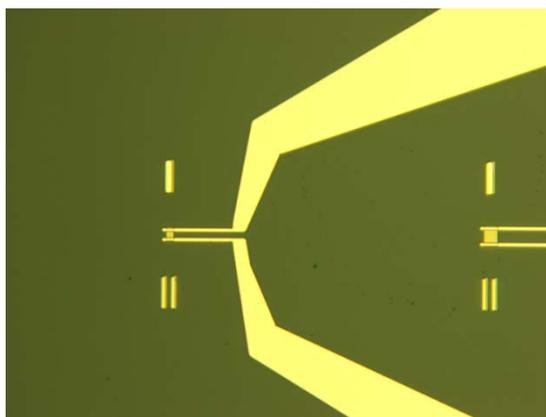


20 μm X 20 μm

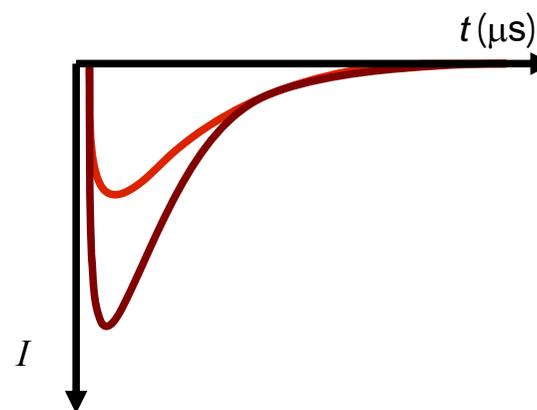
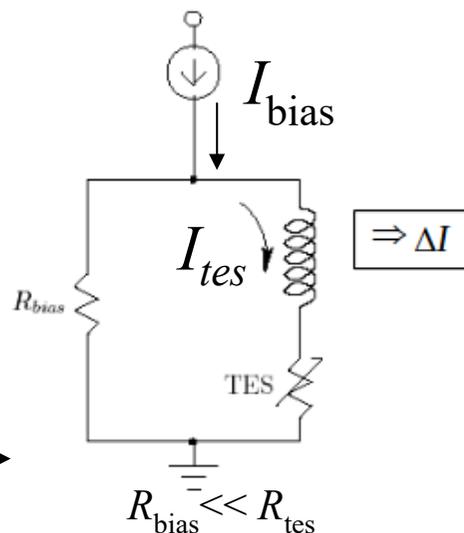
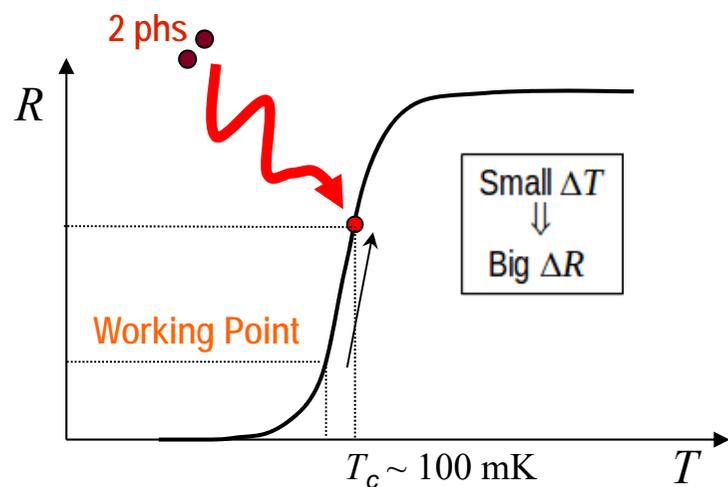


$\Delta T \Rightarrow \Delta R$ @ Voltage bias $\Rightarrow \Delta I$

TESs as single photon detectors



20 μm X 20 μm



$\Delta T \Rightarrow \Delta R$ @ Voltage bias $\Rightarrow \Delta I$

Performances

Transition sharpness

$$\tau_{eff} = \tau_{th} \left\{ 1 + \frac{\alpha}{n} \left(1 - \frac{T_s^n}{T_c^n} \right) \right\}^{-1} \approx \frac{n}{\alpha} \tau_{th} \approx \frac{C}{G} \propto T_c^{-3} \quad \text{Effective response time}$$

↕ Trade-off between response time and energy resolution

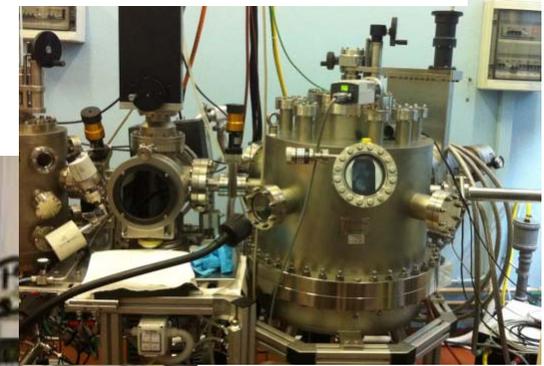
$$\Delta E_{FWHM} \approx 2.36 \sqrt{4kT_0^2 \frac{C_e}{\alpha} \sqrt{n/2}} \propto T_c^{3/2} \quad \text{Energy resolution}$$

↕ Trade-off between energy resolution and saturation energy

$$E_{max} \approx \frac{CT_c}{\alpha} \quad \text{Saturation Energy}$$

INRIM-NM fabrication facility

- Sputtering Nb/Al technology
- UHV system Ti, MgB₂, Nb
- E-beam evaporator Ti/Au, AuPd, SiO_x, etc
- Optical lithography, RIE, ion milling for thin film pattern
- Wedge Bonder system



Sputtering system



Mask aligner

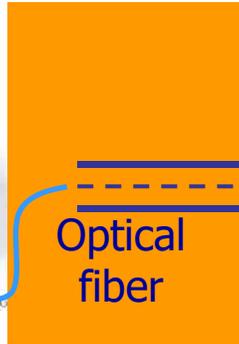


TES: photon counting

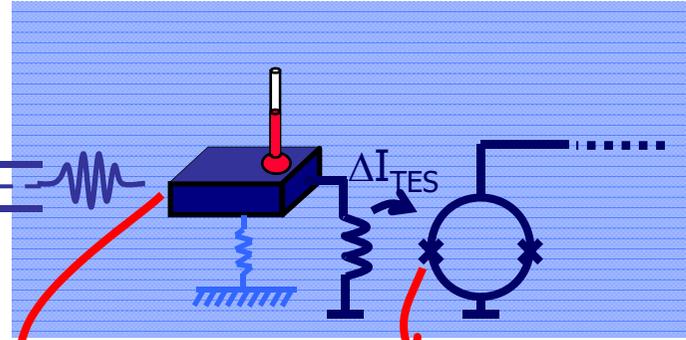
Laser



Attenuator



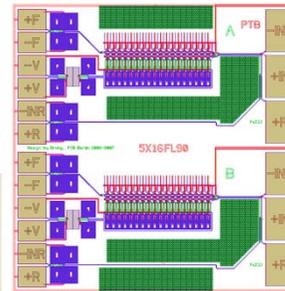
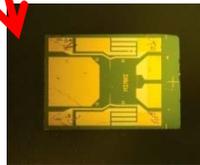
Optical fiber



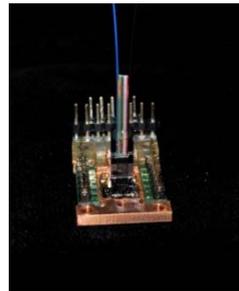
Electronics
& data
aquisition



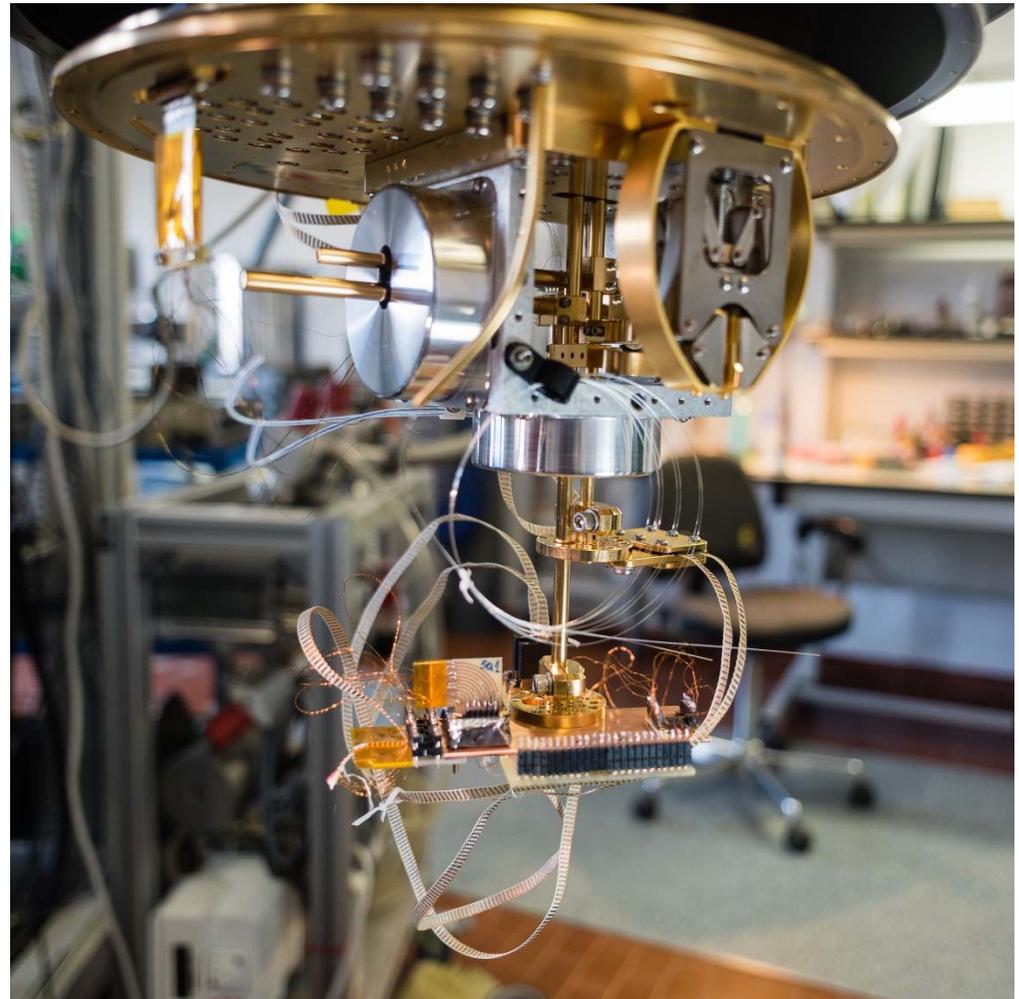
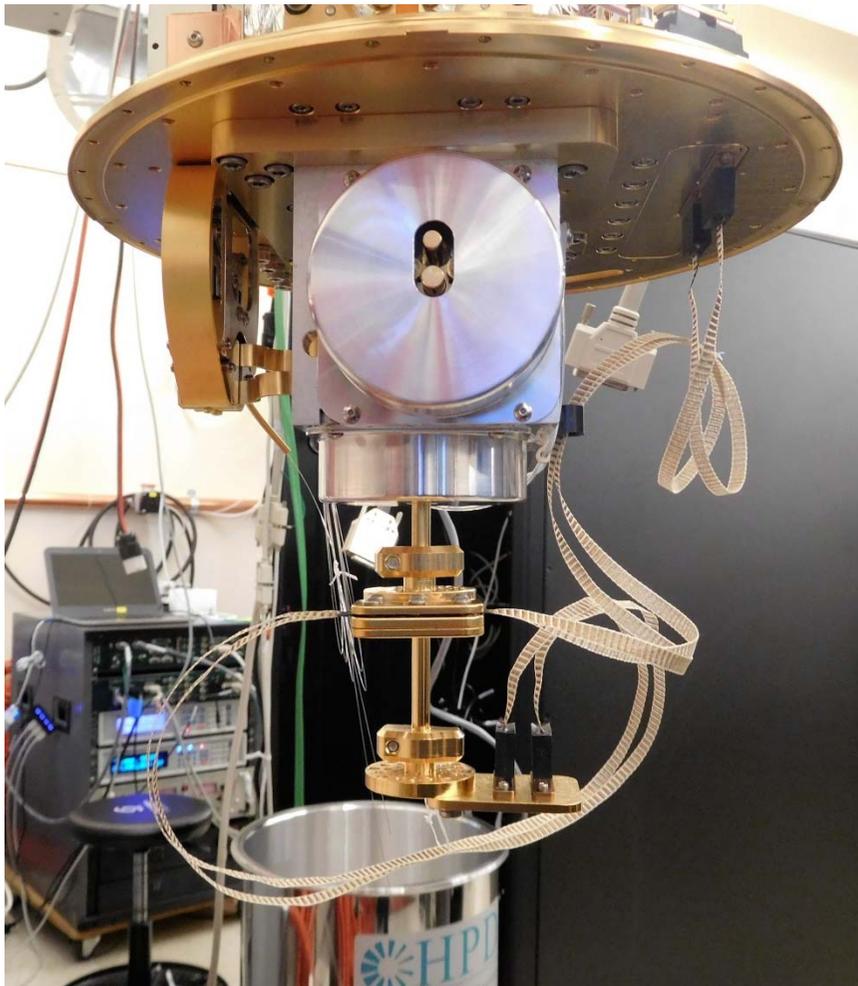
INRiM: TES
module



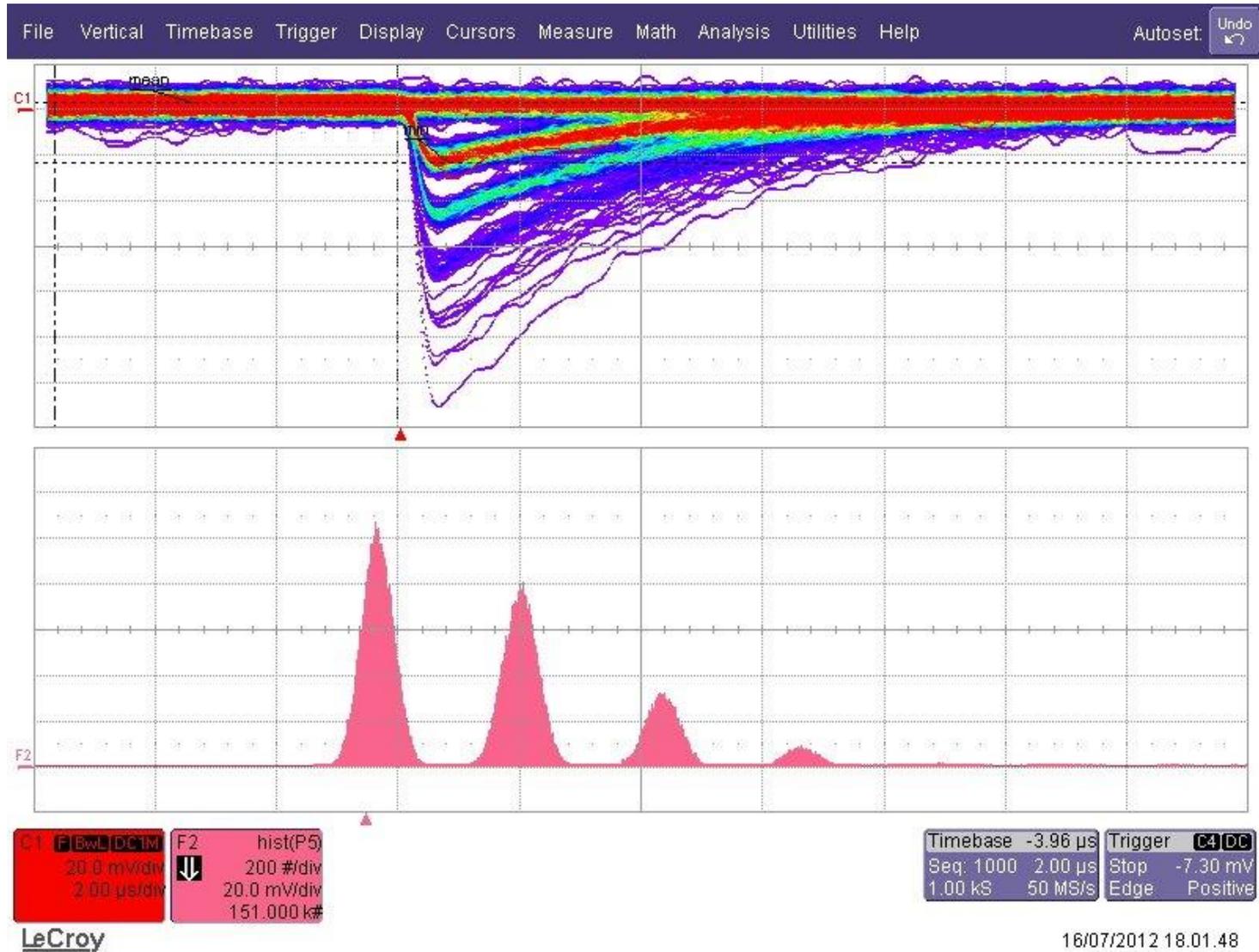
SQUID current
sensors (PTB)



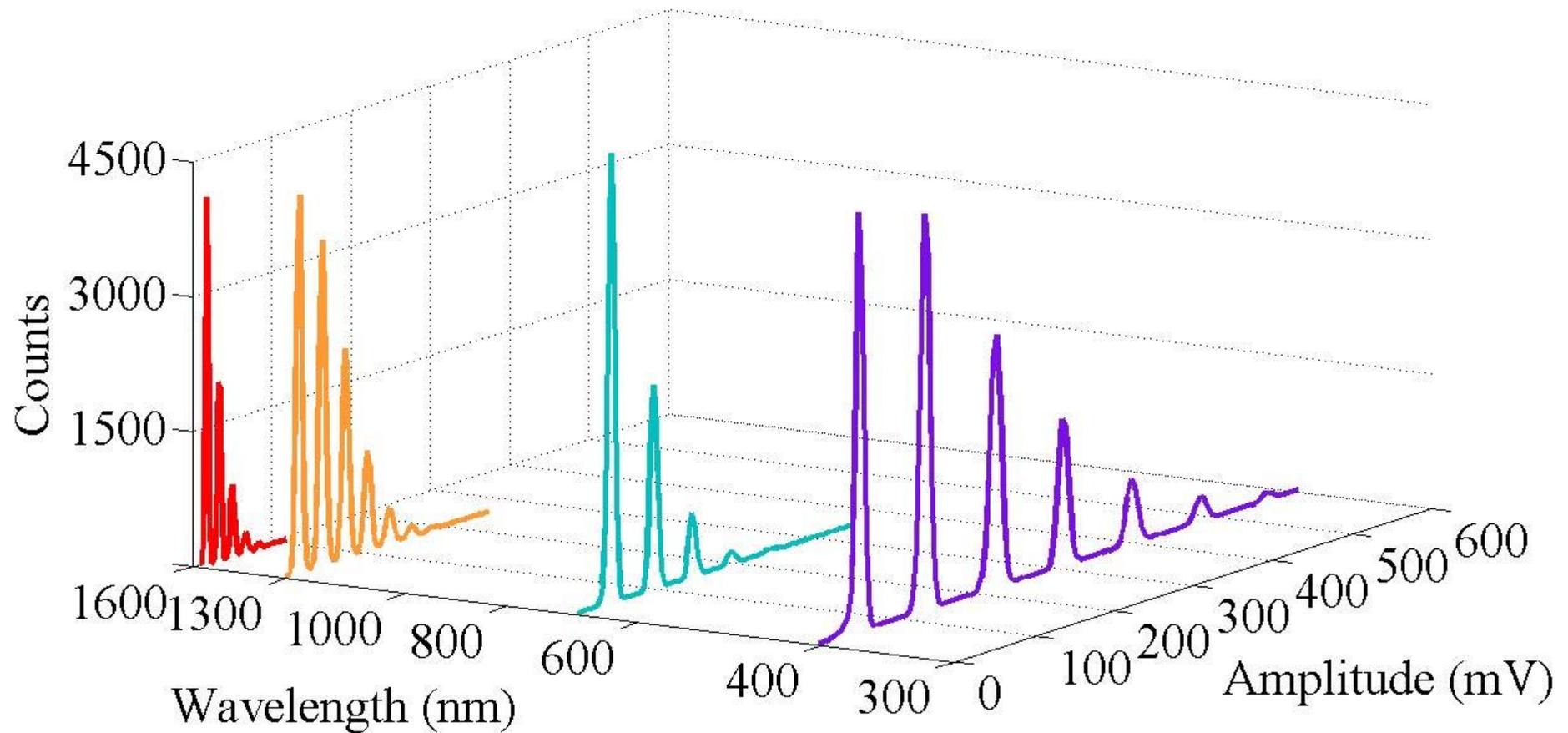
$T_{\min} = 30 \text{ mK}$ - Hold time @ $T=50\text{mK}$: 39 h - Hold time @ $T=100\text{mK}$: >150 h



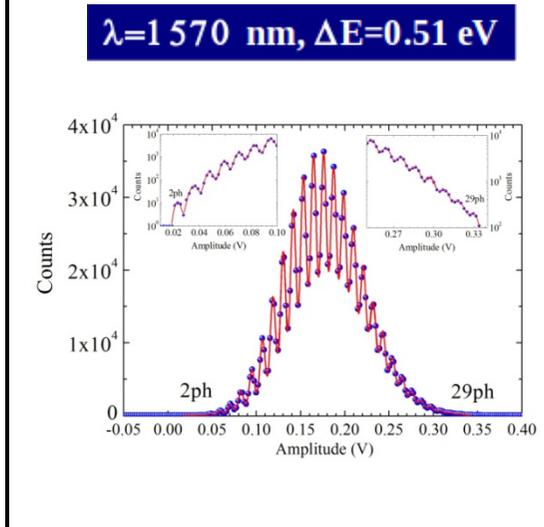
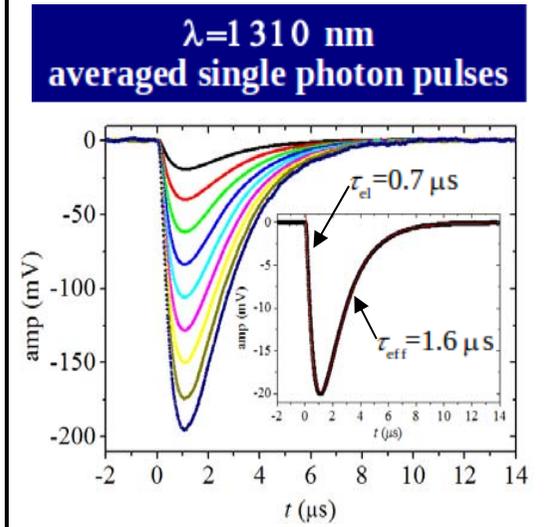
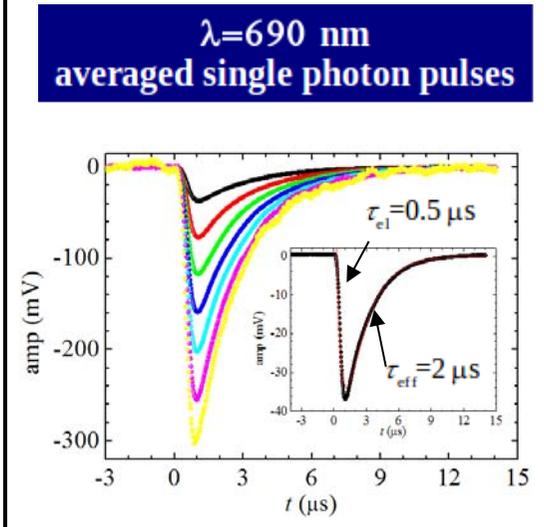
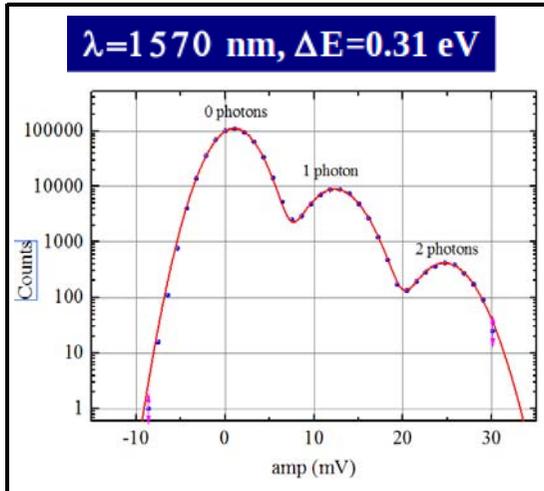
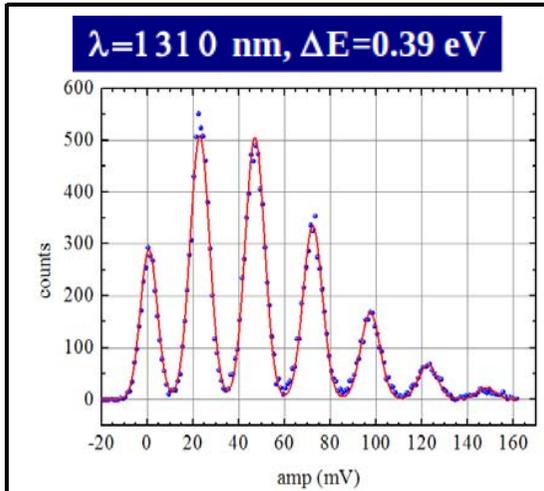
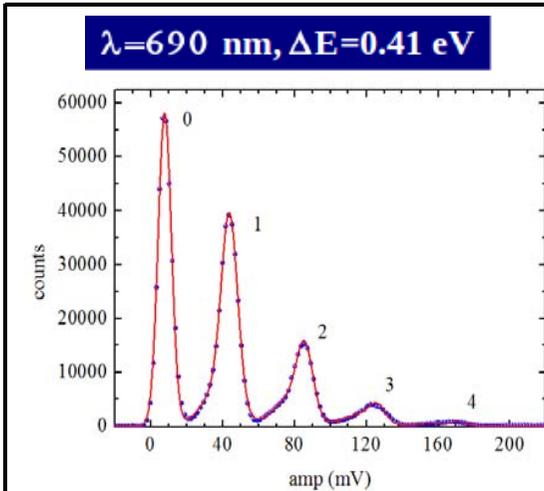
TES: photon counting



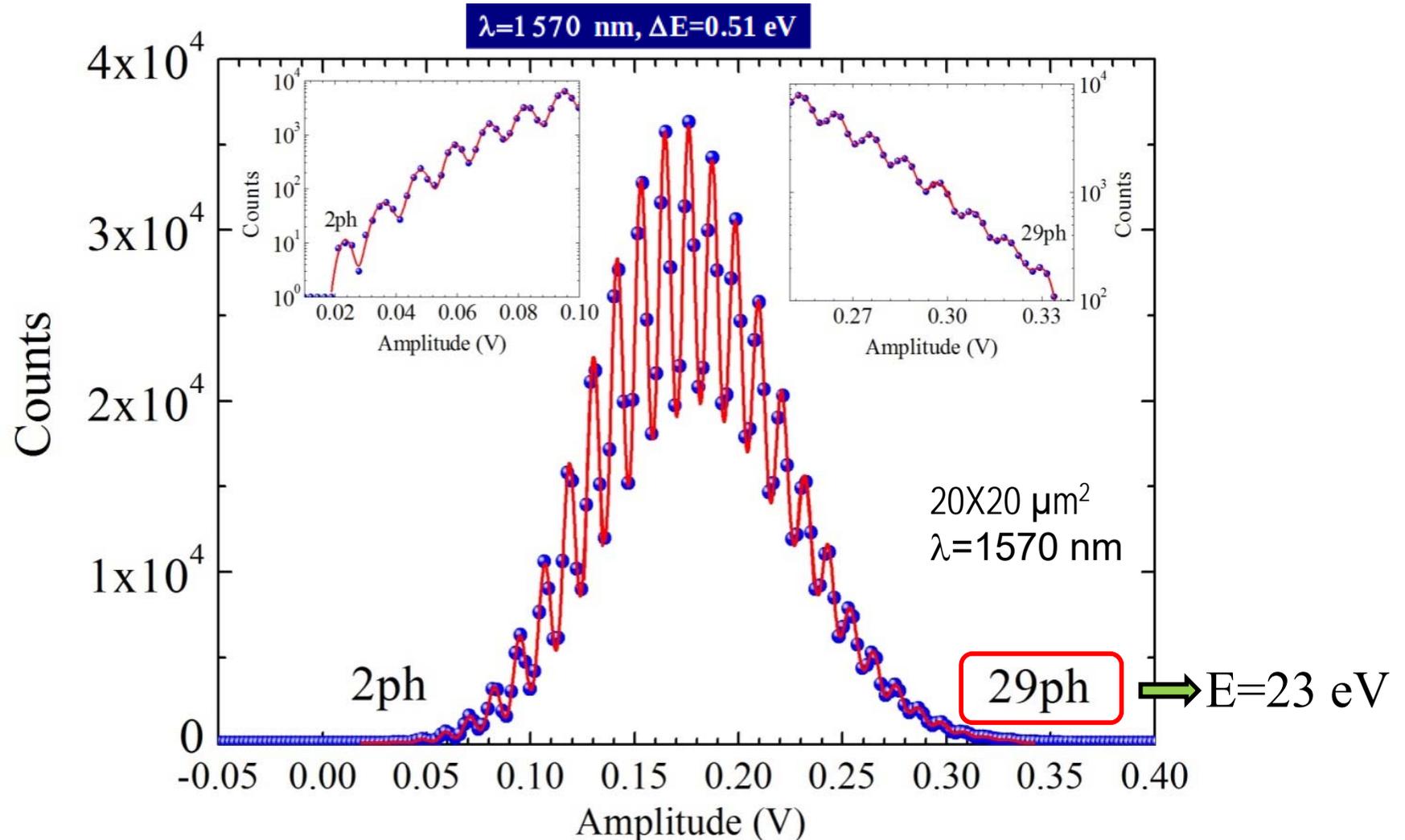
TES: photon counting



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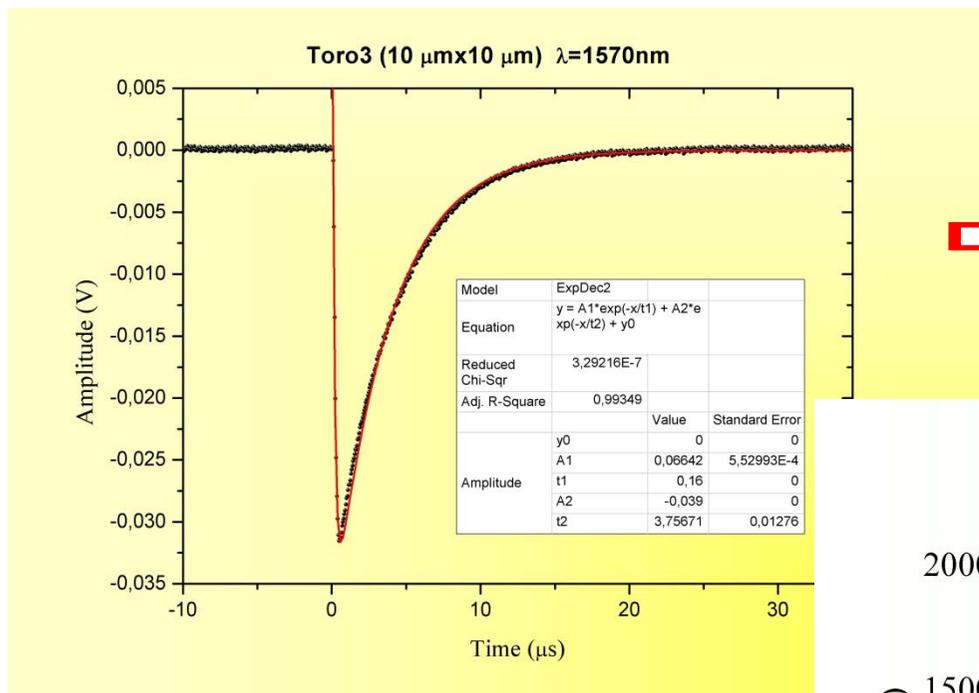


TES: photon counting



L. Lolli, et al. *J. Low Temp. Phys.*, vol. 167, pp. 803-808, 2012.

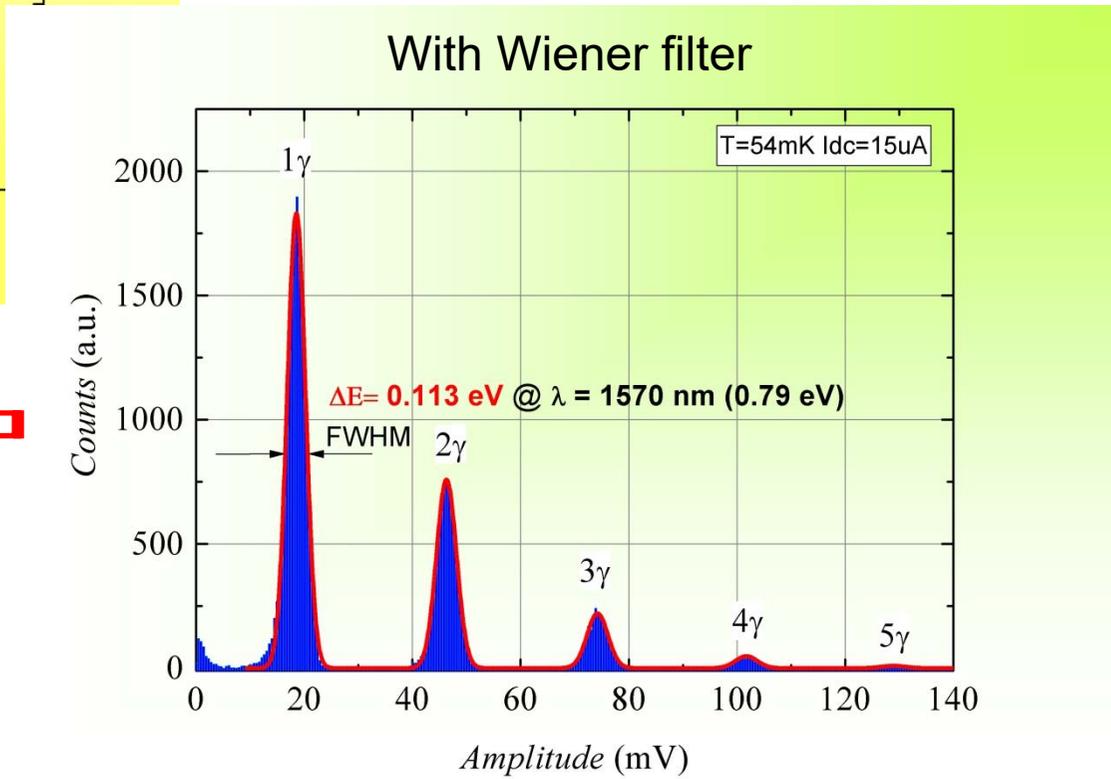
TES: High energy resolution



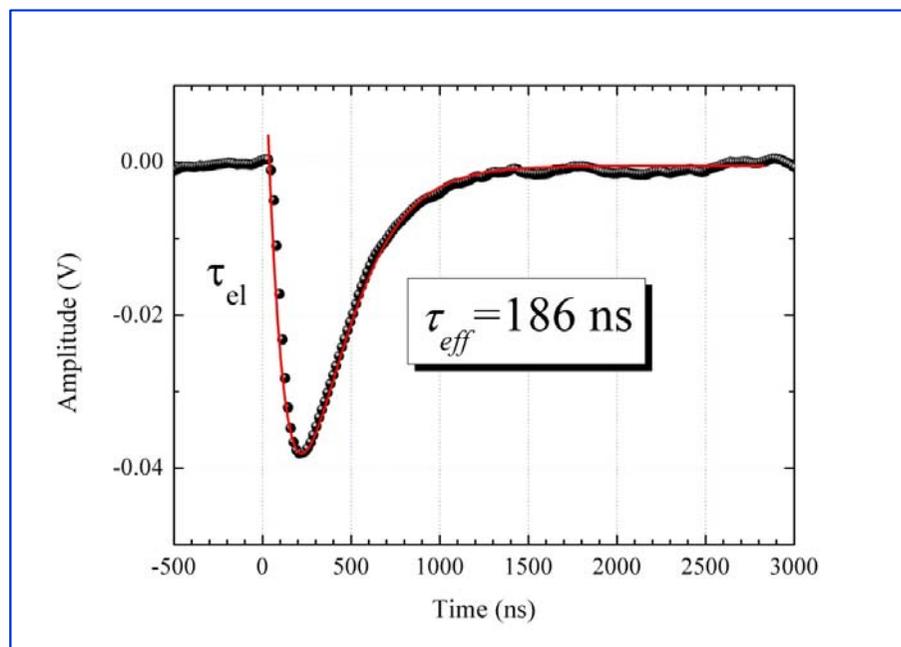
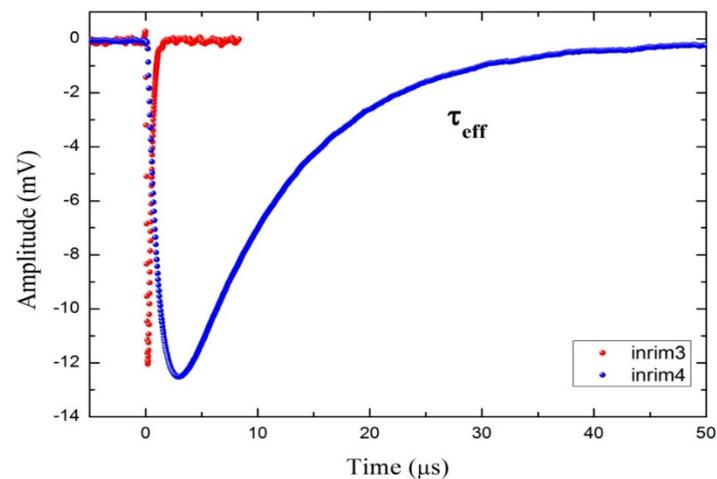
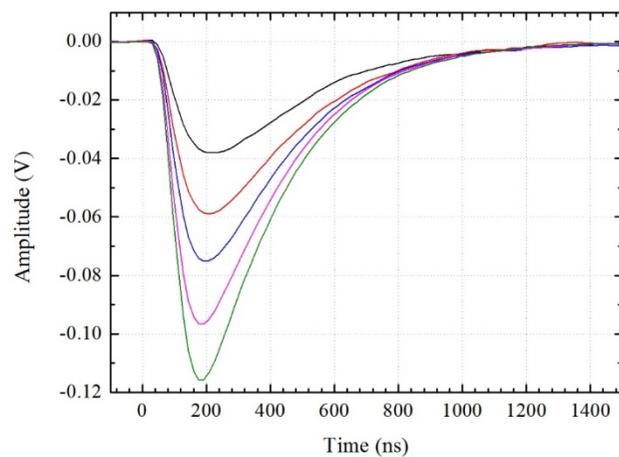
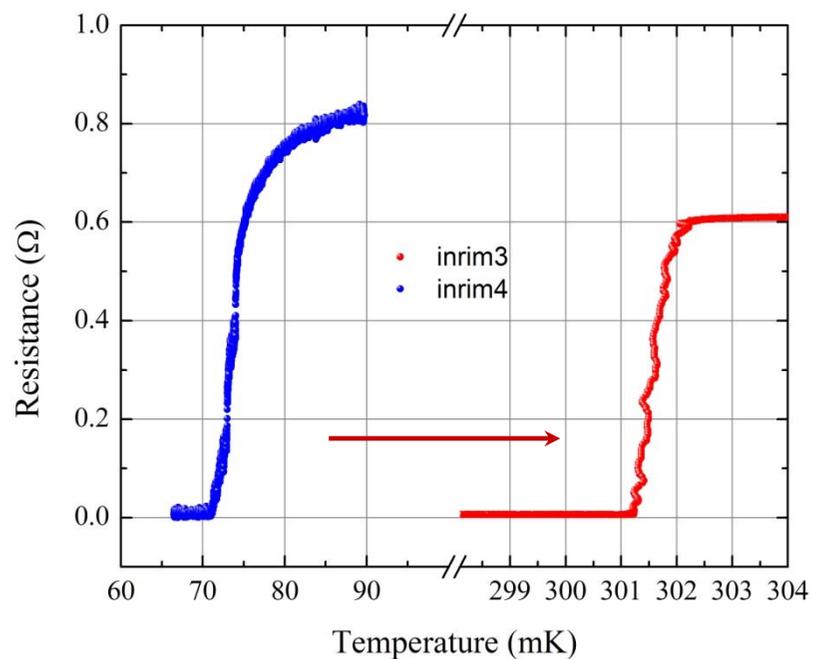
$\tau_{eff} = 3.8 \mu s$

$\Delta E = (0.113 \pm 0.001) \text{ eV}$

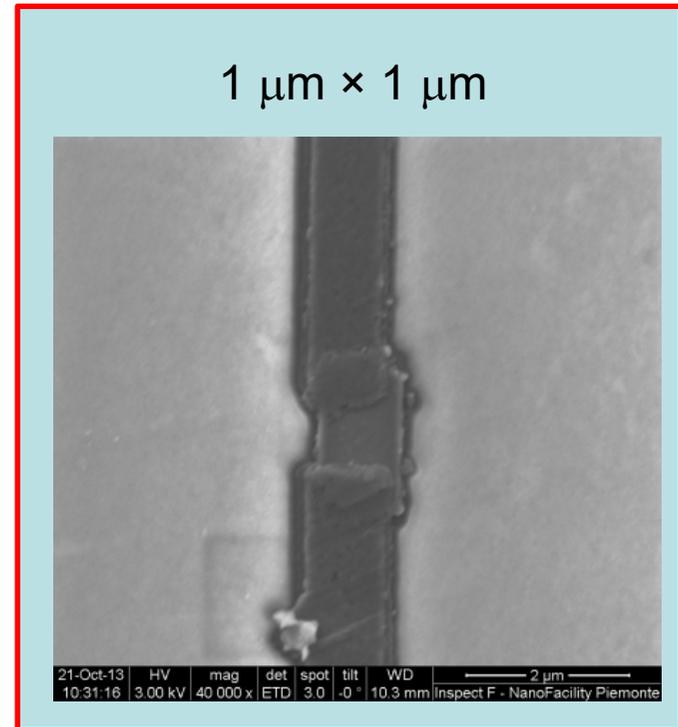
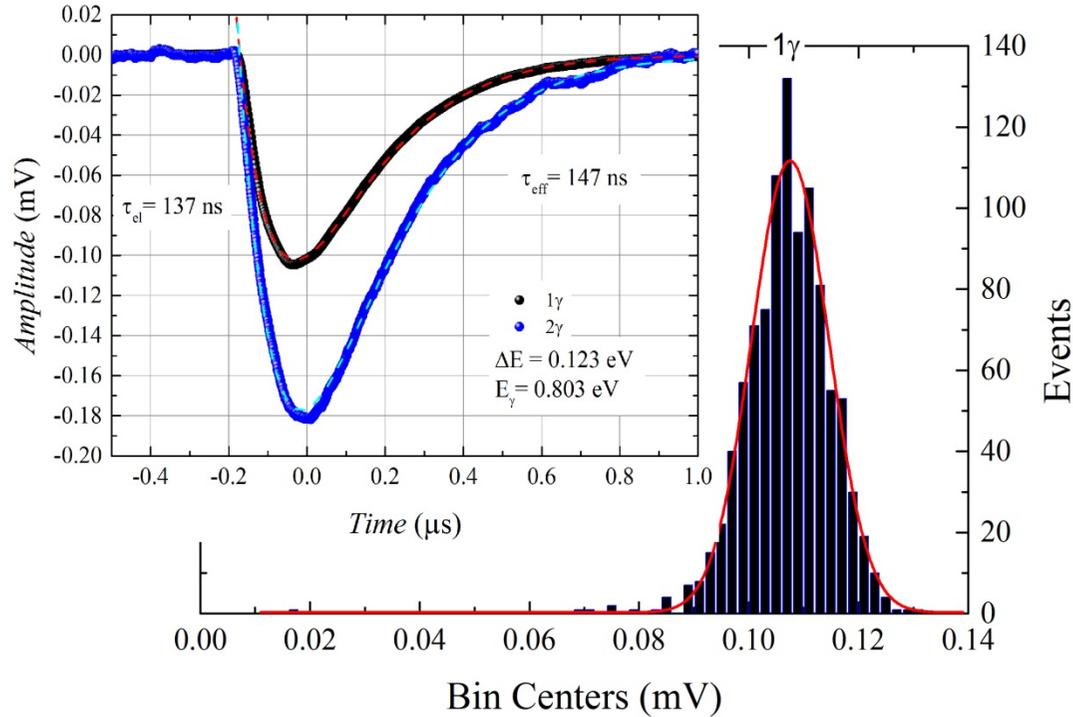
$$\Delta E = 2\sqrt{2 \ln 2} \frac{\sigma_1 E_\gamma}{x_{2\gamma} - x_{1\gamma}}$$



Fast TES



1 μm x 1 μm TES photon counting



$\tau_{\text{etf}} = 147 \text{ ns}$ $\Delta E_{\text{FWHM}} = 0.12 \text{ eV}$
@ 1545 nm

C. Portesi *et al*, IEEE Trans App Supercond, 25, 3, (2015)

Quantum efficiency

QE is limited by



Film reflectance (~50 %)

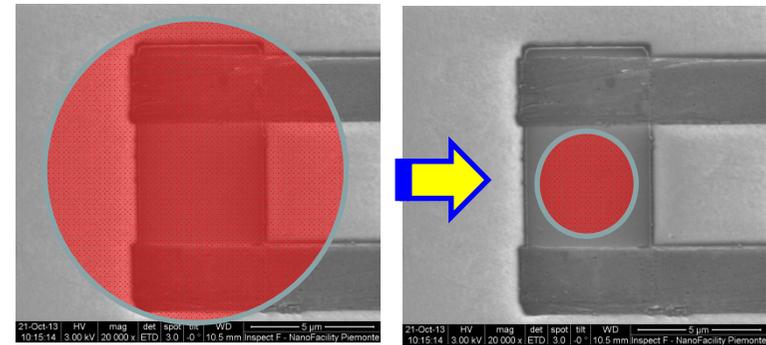
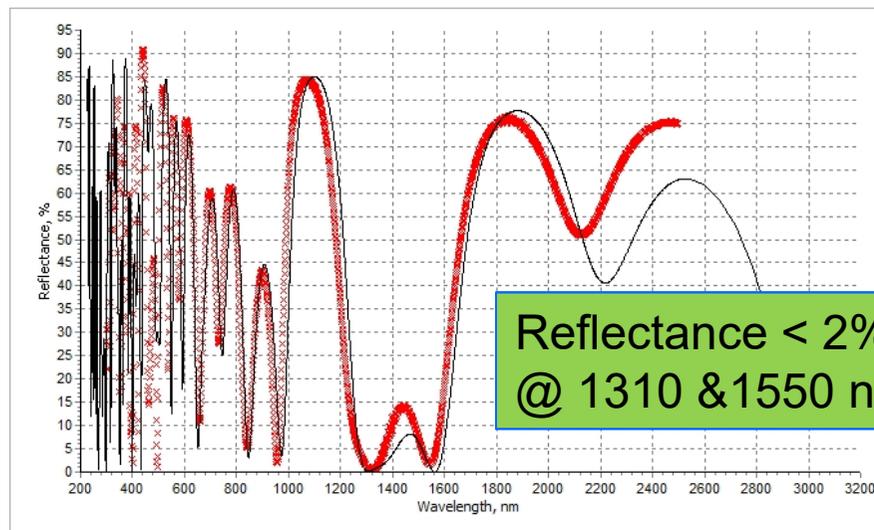


optical coupling

Antireflection coating

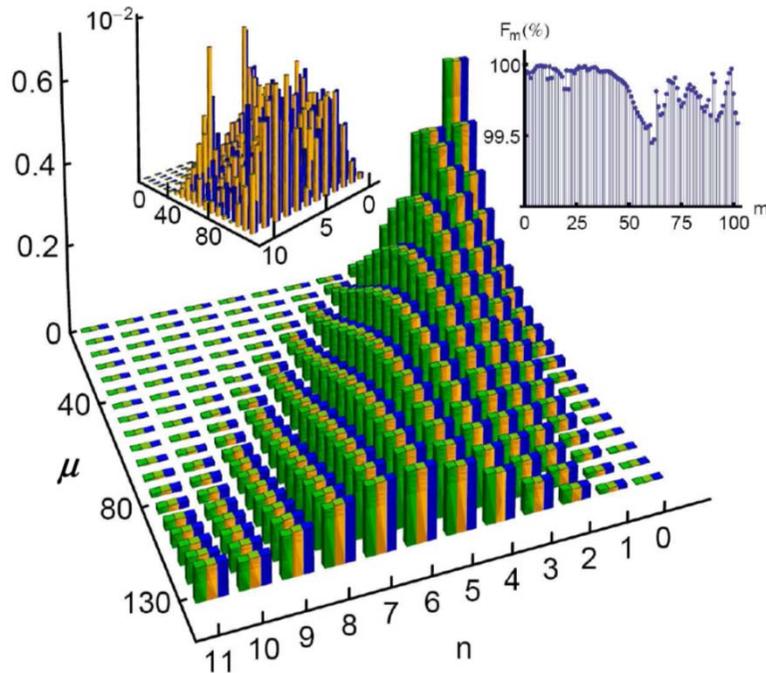
(2.7 μm of multilayers ($\text{Ta}_2\text{O}_5/\text{SiO}_2$))

(in collaboration with Thin Film Laboratory, ENEA)



- For TESs $\geq 5 \mu\text{m} \times 5 \mu\text{m}$ QE > 90% demonstrated (NIST, AIST)
- For TESs $< 1 \mu\text{m} \times 1 \mu\text{m}$ expected $\text{QE}_{\text{max}} \sim 10\%$ with small core fibers

Linear Detection Model



$$\Pi_n = \sum_{m=n}^{\infty} B_{nm} |m\rangle \langle m|$$

$$B_{nm} = \binom{m}{n} \eta^n (1 - \eta)^{m-n}$$

G. Brida *et al*, New Journal of Physics 14 (2012) 085001

Source Emission Statistics

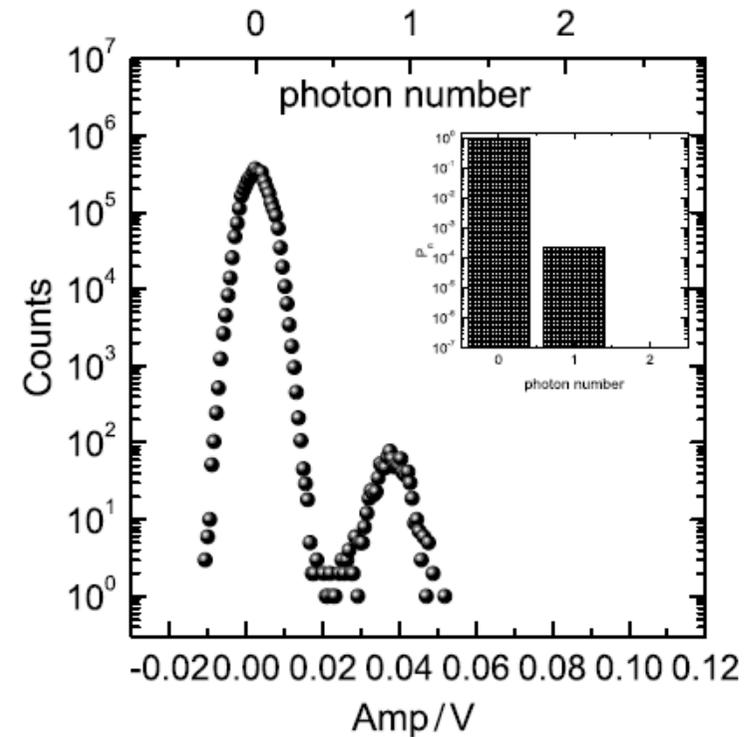
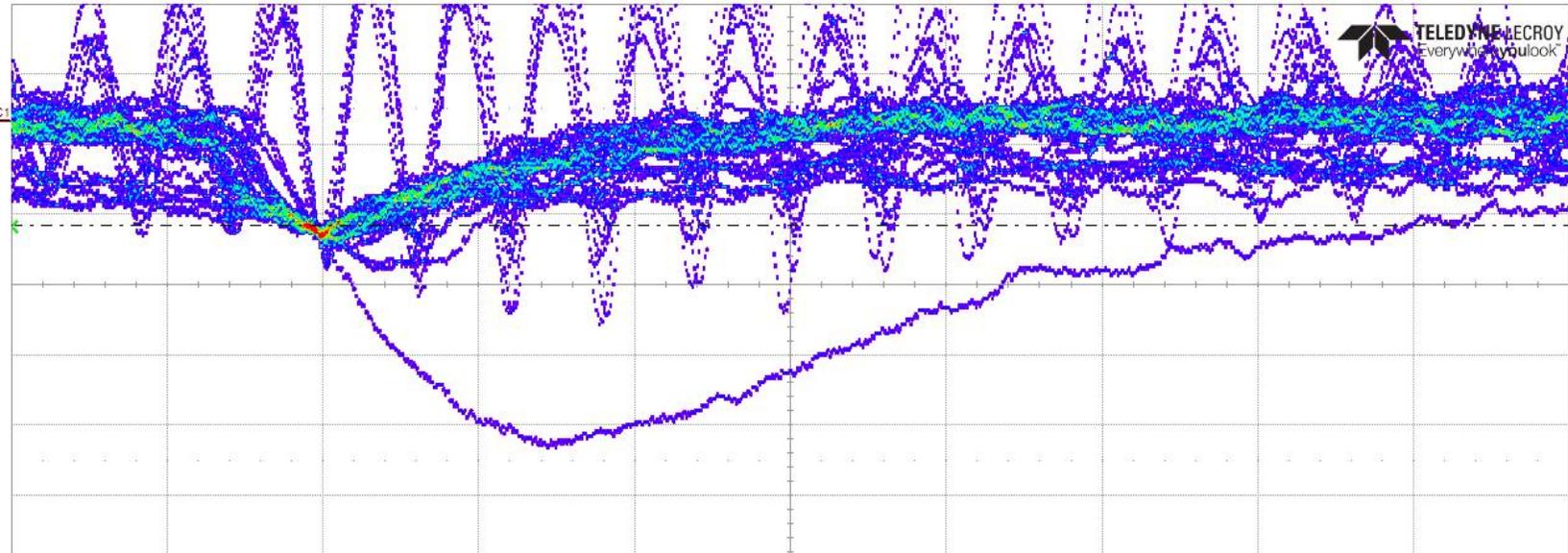


Figure 3. TES histogram of a single NV centre (centre 1).

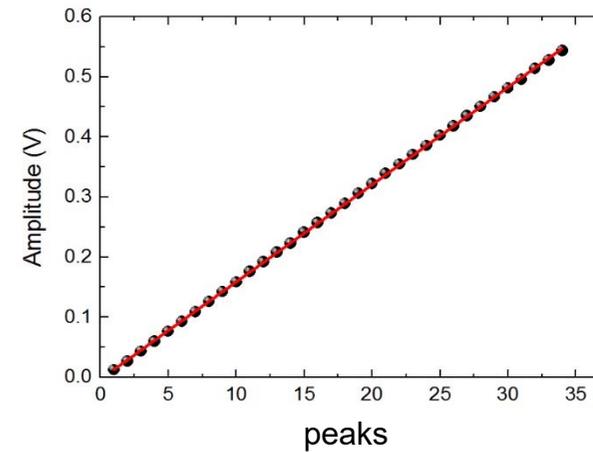
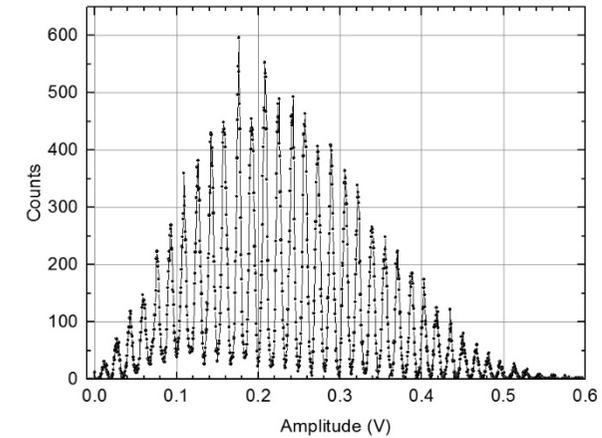
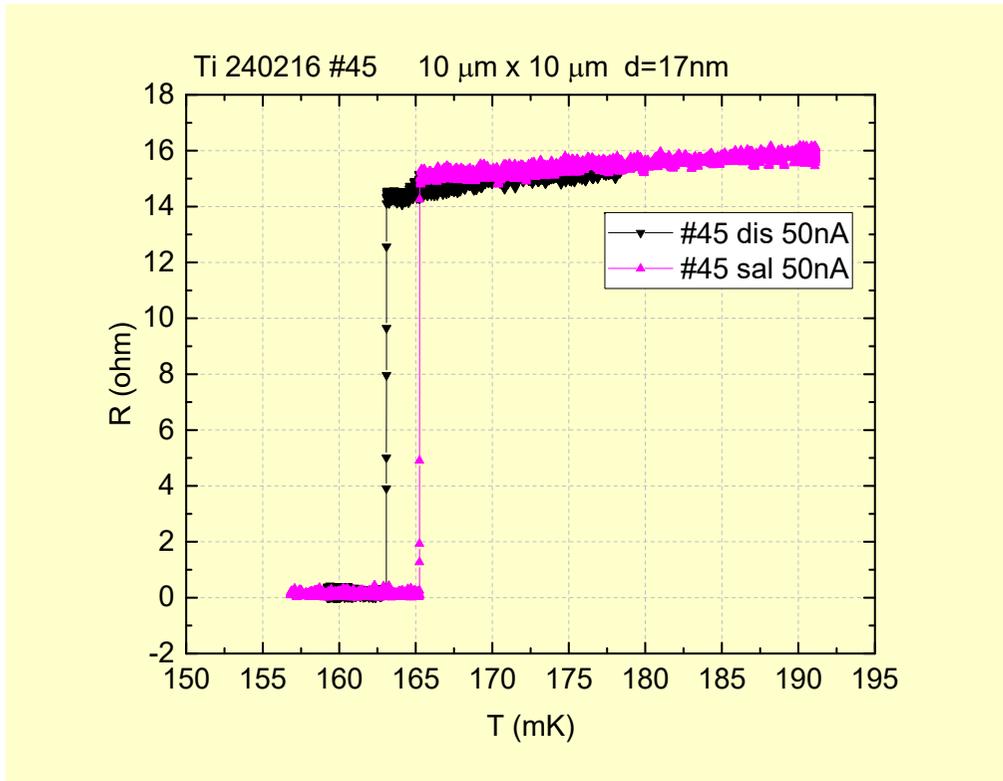
W. Schmunk *et al*, Metrologia 49 (2012) S156-S160

Dark counts rate



1X1 μ m Ti TES: 39 counts/13h \sim 8X10⁻⁴ Hz

Many-Photons detection



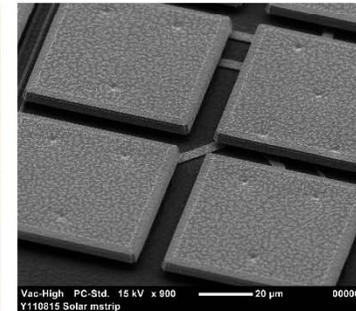
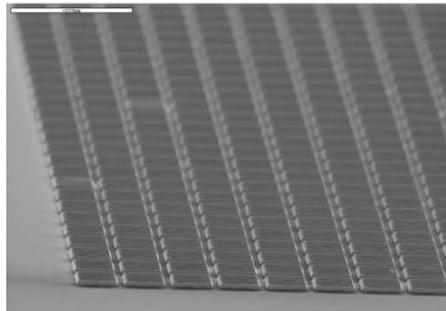
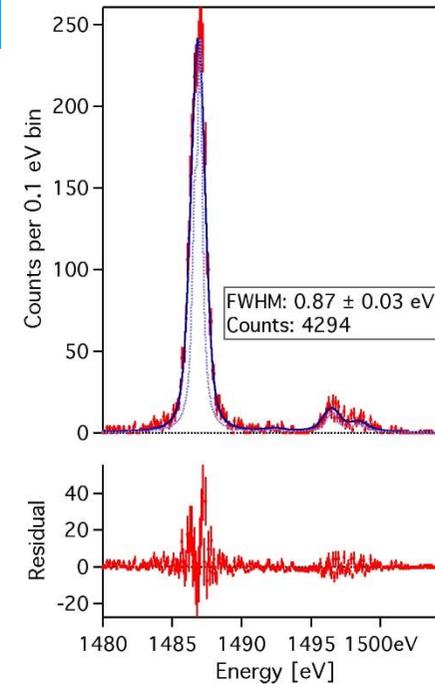
TES: X-ray

From S.R. Bandler NASA

TES 36 μm x 33 μm

Conclusions:

- Excellent energy resolution achieved in small, low heat capacity x-ray microcalorimeters with low Tc
 - ✧ FWHM = 0.9 eV at 1.5 keV
 - ✧ FWHM = 1.6 eV at 6 keV
- Excellent energy resolution demonstrated in 2x2 & 3x3 Hydras
 - ✧ FWHM = 2.1 eV @ 6 keV in 3x3 Hydra
- More uniform arrays being produced
- Suitable for solar physics & astrophysics applications



TES-VI / ASC meeting, Portland, 2012

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Conclusions and future

TES ⇒ one of the best calorimeter
from NIR to X-ray 😊

• NIR-UV $\Delta E=0.1-0.2$ eV

• X-ray $\Delta E=0.8$ eV @ 1.5 KeV
 $\Delta E=1.6$ eV @ 5.9 KeV

- Imaging ⇒ array (next talk)
- Possibility to improve performances:
↳ **yes** (but remember trade-offs)

Thank you for your attention!